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PATENT

*#12/Response
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TC 2800 MAIL ROOM

Applicant: Hidemi Takasu

Serial No.: 09/212,915

Examiner: M. Estrada

Filed : December 16, 1998

Group Art Unit: 2823

For : PROCESS FOR FABRICATING A
SEMICONDUCTOR DRIVEREQUEST FOR RECONSIDERATION

I hereby certify that this paper is being deposited with the United States
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Date of Deposit

Francis J. Hone
Attorney Name18,662
PTO Reg. No.
SignatureNovember 13, 2001
Date of Signature

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Examiner's Action mailed August 13, 2001 the following
remarks are submitted:

R E M A R K S

The Examiner's rejection of claims 1 and 3-9 as being unpatentable over the
Japanese Patent Publication No. 63-261833, in combination with the Wolf publication